

USSN 10/765,647

PATENT

-1-

I hereby certify that this Correspondence is being facsimile transmitted  
to the Patent and Trademark Office on the date shown below.

Signed: Linda A. Jimura Date: April 14, 2006

Typed Name: Linda A. Jimura

RECEIVED  
CENTRAL FAX CENTER

APR 14 2006

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Laura Wills Mirkarimi

Group Art Unit: 1765

Serial No.: 10/765,047

Examiner: Deo

Filed: January 26, 2004

For: METHOD FOR ETCHING HIGH ASPECT RATIO FEATURES IN III-V BASED  
COMPOUNDS FOR OPTOELECTRONIC DEVICES

Attorney Docket No. 10030753-1

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In reply to the Final Office Action in the above identified application, Applicant  
submits the following Amendments and Remarks.